

PTO-1449		Application No. 09/862,814		Applicant(s) John C. Seibel et al.	
Information Disclosure Citation in an Application		Docket Number 067082.0114		Group Art Unit 2177	Filing Date 01-06-04
					5/21/01

DEC 19 2003

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	4914586	4/3/90	Swinehart et al.	364	200	11/6/87
B	6034970	3/7/00	Levac et al.	370	466	7/2/97
C	6199081	3/6/01	Meyerzon et al.	707	513	6/30/98
D	6493703	12/10/02	Knight et al.	707	3	5/11/99
E	6609124	8/19/03	Chow et al.	707	5	8/13/01
F	6611839	8/26/03	Nwabueze	707	101	3/15/01
G						
H						
I						
J						
K						
L						
M						

RECEIVED
JAN 02 2004
Technology Center 2100

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
N							
O							
P							

NON-PATENT DOCUMENTS

	DOCUMENT (Including Author Title Source and Pertinent Pages)	DATE
Q		
R		
S		
T		
U		

EXAMINER: *Kim S. Lu* DATE CONSIDERED: *2/18/2004*

EXAMINER: Initial if citation considered whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.